

IFW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Leonel R. Arana et al. § Group Art Unit:  
Serial No.: 10/807,836 § Examiner:  
Filed: March 24, 2004 § Atty. Dkt. No.: ITL.1133US  
(P19113)  
For: Microfabricated Hot Wire Vacuum § Assignee: Intel Corporation  
Sensor

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

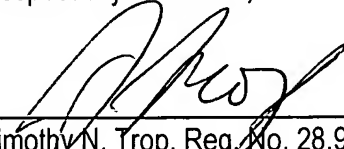
Dear Sir:

Applicant submits the references listed on the attached form PTO 1449, copies of which are enclosed. A copy of a communication dated August 1, 2005 from a foreign patent office in a counterpart application is also enclosed. I, the undersigned, hereby certify that each item of information contained in the Information Disclosure Statement was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of the Information Disclosure Statement. Please apply any charges or credits to Deposit Account No. 20-1504 (ITL.1133US).

Respectfully submitted,

August 4, 2005

Date

  
Timothy N. Trop, Reg. No. 28,994  
Trop, Pruner & Hu, P.C.  
8554 Katy Freeway, Ste. 100  
Houston, TX 77024  
713/468-8880  
713/468-8883 [fax]

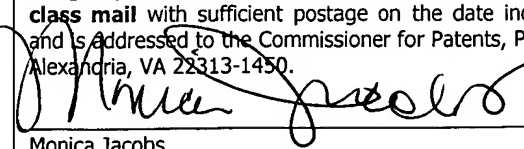
Attorney for Intel Corporation

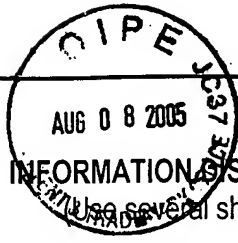
Customer No.

**21906**

Date of Deposit: August 4, 2005

I hereby certify under 37 CFR 1.8(a) that this correspondence is being deposited with the United States Postal Service as **first class mail** with sufficient postage on the date indicated above and is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

  
Monica Jacobs



<b>INFORMATION DISCLOSURE CITATION</b> (Use several sheets if necessary)	ATTY DOCKET NO. ITL.1133US (P19113)	SERIAL NO. 10/807,836
	APPLICANT(S): Leonel R. Arana et al.	
	FILING DATE: March 24, 2004	GROUP ART UNIT:

### U.S. PATENT DOCUMENTS

*EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	A.	6,553,841	04/29/2003	Blouch			
	B.						
	C.						
	D.						
	E.						

### U.S. PATENT APPLICATION PUBLICATIONS

	F.	2003/0073292	04/17/2003	Bartlett et al.			
	G.						
	H.						
	I.						
	J.						

### FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
							YES	NO
	K.	DE 43 24 119	01/27/1994	Germany				X
	L.	DE 100 49 556	06/13/2001	Germany				X
	M.	DE 199 03 010	08/17/2000	Germany				X
	N.	JP 63-284835	11/22/1988	Japan			Abstract Only	
	O.	JP 2001-324403	11/22/2001	Japan			Abstract Only	

### OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

	P.	
	Q.	
	R.	
	S.	
	T.	
	U.	
	V.	

EXAMINER

DATE CONSIDERED

\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.